



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/212,726
Filing Date December 15, 1998
Inventor..... Klaus F. Schuegraf
Assignee..... Micron Technology, Inc.
Group Art Unit..... 2813
Examiner Kielin, Erik J.
Attorney's Docket No. MI22-1098
Title: Semiconductor Processing Methods of Chemical Vapor Depositing SiO₂ on a
Substrate

RESPONSE TO SEPTEMBER 27, 2004 FINAL OFFICE ACTION
TO ACCOMPANY RCE FILING

To: Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENTS

Introductory Comments

In reply to the office action dated September 27, 2004, applicant amends and
remarks as follows.